

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: KITAOKA et al.

Docket: 10873.1391US01

Title: METHOD OF MANUFACTURING GROUP III NITRIDE SUBSTRATE AND  
SEMICONDUCTOR DEVICE

---

CERTIFICATE UNDER 37 CFR 1.10

'Express Mail' mailing label number: EV 321729447 US

Date of Deposit: January 15, 2004

I hereby certify that this paper or fee is being deposited with the United States Postal Service 'Express Mail Post Office To Addressee' service under 37 CFR 1.10 and is addressed to Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

By: \_\_\_\_\_  
Name: John Junkers

**PRELIMINARY AMENDMENT**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In connection with the above-identified application filed herewith, please enter  
the following preliminary amendment:

**Amendments to the claims** are reflected in the listing of claims which begins on  
page 2 of this paper

**Remarks** begin on page 7 of this paper.